

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: S. Deliwala

Serial No.: 10/078,203

Filed: February 19, 2002

For: FOCUSING MIRROR AND LENS



Examiner: Not yet known

Group No.: 3653

Attorney Docket No.: 53168-50030

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INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§ 1.56 ET SEQ.

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Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In accordance with 37 C.F.R. § 1.97(b), the above-identified Applicant cites the following patents and publications, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 C.F.R. § 1.56. In compliance with 37 C.F.R. § 1.98(a), copies of the patents and publications set forth below and listed on the attached Form PTO/SB/08A have been provided.

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CERTIFICATE OF MAILING (37 C.F.R. § 1.8)

I hereby certify that this paper, and the papers and/or fees referred to herein as transmitted, submitted or enclosed, are being deposited on the date shown below with the U.S. Postal Service with sufficient postage as first-class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Name Daniel H. Golub

Signature [Signature]

Date of Deposit April 11, 2002

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U.S. Patent Document No.	Patentee	Publication Date
5,880,491	Soref et al.	03/09/99
5,875,271	Laughlin	02/23/99
5,841,916	Laughlin	11/24/98
6,114,994	Soref et al.	09/05/00
5,354,709	Lorenzo et al.	10/11/94
5,260,592	Mead et al.	11/09/93
6,163,632	Rickman et al.	12/19/00
5,908,305	Crampton et al.	06/01/99
5,757,986	Crampton et al.	05/26/98
6,002,515	Mizuuchi et al.	12/14/99
5,894,492	Welch et al.	04/13/99
6,088,496	Asghari	07/11/00
5,444,567	Kataoka	08/22/95
5,926,601	Tai et al.	07/20/99
6,222,689 B1	Higuchi et al.	04/24/01
5,577,141	Adar et al.	11/19/96
5,652,681	Chen et al.	07/29/97
5,513,289	Hosokawa et al.	04/30/96
6,282,357 B1	Kadota et al.	08/28/01
6,017,681	Tsukamoto et al.	01/25/00
6,259,841 B1	Bhagavatula	07/10/01
6,289,699 B1	Kewitsch et al.	09/18/01

Foreign Patent Document No.	Patentee/Applicant	Publication Date
WO-99/09514-A1	Advanced Precision	02/25/99
WO-01/20372-A2	Corning Incorporated	03/22/01
WO-01/56119-A2	Lambda Physik	08/02/01
WO-01/01530-A1	Lambda Physik	01/04/01
WO-00/58776-A1	Bookham Technology	10/05/00
WO-00/49451-A1	Bookham Technology	08/24/00
WO-99/60433-A1	Bookham Technology	11/25/99
WO-99/34485-A1	Bookham Technology	07/08/99
WO-01/50166-A1	Bookham Technology	07/12/01
WO-98/35253-A1	Bookham Technology	08/13/98
WO-00/25156-A1	Bookham Technology	05/04/00
WO-01/67172-A1	Bookham Technology	09/13/01

Applicant respectfully requests that these items be considered by the Examiner, and that the Examiner acknowledge consideration of these references by initialing and returning copies of the enclosed Form PTO/SB/08A with the next official action.

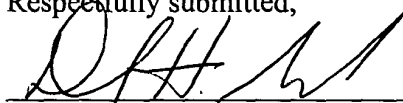
Applicant also wishes to bring to the Examiner's attention the applications set forth on Exhibit A, all of which are owned by the assignee of the present invention, and which may disclose or claim subject matter in respect of which there may be a duty to disclose.

While this Information Disclosure Statement may be "material" pursuant to 37 C.F.R. § 1.56, it is not intended to constitute an admission that any patent, publication or other information referred to herein is "prior art" for this invention or otherwise material to the patentability of this invention as defined in 37 C.F.R. § 1.56.

In accordance with 37 C.F.R. § 1.97(g), the filing of this Information Disclosure Statement shall not be construed as a representation that a search has been made or that no other material information as defined in 37 C.F.R. § 1.56(b) exists.

The Commissioner is hereby authorized to charge any deficiency in the fees due for this Information Disclosure Statement to Deposit Account No. 50-0310. A duplicate of this paper is enclosed.

Respectfully submitted,



Daniel H. Golub
Reg. No. 33,701
Attorney for Applicant

MORGAN, LEWIS & BOCKIUS LLP
1701 Market Street
Philadelphia, PA 19103-2921
215.963.5055

Dated: April 11, 2002

EXHIBIT A

Docket No.	TITLE	INVENTORS	PATENT/ SERIAL NO.	ISSUE/ FILING DATE
053168-5003	Electronic Semiconductor Control of Light in Optical Waveguide	S. Deliwala	09/859,693	05/17/01
053168-5003-01	Integrated Optical/Electronic Circuits and Associated Methods of Simultaneous Generation Thereof	S. Deliwala	09/991,542	11/10/01
53168-500301D1	Optical Coupler Having Evanescent Coupling Region	S. Deliwala	10/074,408	02/12/02
53168-500301D2	Method of Forming Passive Optical Coupling Device	S. Deliwala	10/077,026	02/15/02
53168-500301D3	Simulation Program for Integrated Optical/Electronic Circuit	S. Deliwala	10/076,920	02/15/02
53168-500301D4	Shallow Photonic Bandgap Device	S. Deliwala	10/078,972	02/19/02
53168-500301D6	Hybrid Active and Electronic Circuit with Evanescent Coupling	S. Deliwala	10/079,668	02/20/02
53168-500301D7	Hybrid Active Electronic and Optical Fabry Perot Cavity	S. Deliwala	10/079,310	02/20/02
53168-500301D8	Hybrid Multiplexer/Demultiplexer	S. Deliwala	10/079,073	02/20/02

053168-5003-02	Anisotropic Etching of Optical Components	S. Deliwala K. Montgomery	09/991,371	11/10/01
053168-5004	Optical Modulator Apparatus and Associated Method	S. Deliwala	09/859,297	05/17/01
053168-5005	Optical Lens Apparatus and Associated Method	S. Deliwala	09/859,647	05/17/01
053168-5006	Optical Deflector Apparatus and Associated Method	S. Deliwala	09/859,239	05/17/01
053168-5007	Optical Filter Apparatus and Associated Method	S. Deliwala	09/859,338	05/17/01
053168-5008	Dynamic Gain Equalizer Apparatus and Associated Method	S. Deliwala	09/859,279	05/17/01
053168-5009	Self-Aligning Modulator Apparatus and Associated Method	S. Deliwala	09/859,769	05/17/01
053168-5010	Programmable Delay Generator Apparatus and Associated Method	S. Deliwala	09/859,321	05/17/01
053168-5011	Polarization Control Apparatus and Associated Method	S. Deliwala	09/859,663	05/17/01
053168-5012	Interferometer Apparatus and Associated Method	S. Deliwala	09/859,786	05/17/01



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PTO/SB/08A (10-01)

Approved for use through 10/31/2002. OMB 0651-0031
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Complete if Known			
		Application Number	10/078,203		
		Filing Date	02/19/2002		
		First Named Inventor	Dehewala		
		Art Unit	3653		
		Examiner Name	Not yet known		
Sheet	1	of	2	Attorney Docket Number	53164-500301DS

U.S. PATENT DOCUMENTS					
Examiner Initials ¹	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
	A	US-5,880,491	03-09-1999	Soret et al.	
	B	US-5,875,271	02-23-1999	Laughlin	
	C	US-5,841,916	11-24-1998	Laughlin	
	D	US-6,114,994	09-05-2000	Soret et al.	
	E	US-5,354,709	10-11-1994	Lorenzo et al.	
	F	US-5,260,592	11-09-1993	Mead et al.	
	G	US-6,163,632	12-19-2000	Rickman et al.	
	H	US-5,908,305	06-01-1999	Crampton et al.	
	I	US-5,757,986	05-26-1998	Crampton et al.	
	J	US-6,002,515	12-14-1999	Mizunuchi et al.	
	K	US-5,874,492	04-13-1999	Welch et al.	
	L	US-6,088,496	07-11-2000	Asghari	
	M	US-5,444,567	08-22-1995	Katanka	
	N	US-5,926,601	07-20-1999	Lai et al.	
	O	US-6,222,689B1	04-24-2001	Higuchi et al.	
	P	US-5,572,141	11-19-1996	Adar et al.	
	Q	US-5,652,681	07-29-1997	Chen et al.	
	R	US-5,513,289	04-30-1996	Hosokawa et al.	
	S	US-6,282,357B1	08-28-2001	Kadota et al.	
	T	US-6,012,681	01-25-2000	Tsukamoto et al.	

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FOREIGN PATENT DOCUMENTS					
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)			
	U	WO-99/09514-A1	02-25-1999	Advanced Precision	
	V	WO-01/20372-A2	03-22-2001	Corning Incorporated	
	W	WO-01/56119-A2	08-02-2001	Lambda Physik	
	X	WO-01/01530-A1	01-04-2001	Lambda Physik	
	Y	WO-00/58776-A1	10-05-2000	Bookham Tech.	
	Z	WO-00/44451-A1	08-24-2000	Bookham Tech.	
	AA	WO-99/60433-A1	11-25-1999	Bookham Tech.	
	BB	WO-99/34485-A1	07-08-1999	Bookham Tech.	
	CC	WO-01/50166-A1	07-12-2001	Bookham Tech.	
	DD	WO-98/35253-A1	08-13-1998	Bookham Tech.	

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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